

<b>Information Disclosure Citation in an Application</b>	Application No. 10/760,443	Applicant(s) Eoff et al.	
	Docket Number HES 2001-IP-005267U1P1	Group Art Unit 1712	Filing Date January 20, 2004

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	DOCUMENT NO.	ISSUE/PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE
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	2,819,278	01/07/58	De Groot et al.			05/09/56
	2,877,179	03/10/59	Hughes et al.			03/26/56
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### NON-PATENT DOCUMENTS

	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	
	Office action dated 12/28/2007 from application serial number 10/806,894	12/28/2007
	Office action dated 7/12/2007 from application serial number 10/806,894	7/12/2007
	Office action dated 4/9/2007 from application serial number 10/806,894	4/9/2007
	Office action dated 1/3/2007 from application serial number 10/806,894	1/3/2007
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	Notice of allowance dated 1/28/2008 from application serial number 11/102,062	1/28/2008
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	Notice of allowance dated 5/25/2006 from application serial number 10/881,198	5/25/2006
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	Office action dated 9/12/2006 from application serial number 10/893,210	9/12/2006
	Office action dated 1/14/2008 from application serial number 11/471,148	1/14/2008

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	Office action dated 11/2/2007 from application serial number 11/471,148		11/2/2007
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